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PATENT
Atty. Dkt. No. AMAT/4969/CMP/ECP/RKK

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Mok, et al.

Serial No.: 09/785,815

Confirmation No.: 4127

Filed: February 16, 2001

For: Integrated Semiconductor
Substrate Bevel Cleaning
Apparatus and Method

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 1763

Examiner: Sylvia MacArthur

CERTIFICATE OF MAILING
37 CFR 1.8

I hereby certify that this correspondence is being deposited on June 25, 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

6/25/03
Date

B. Todd Patterson
Signature

RESPONSE TO OFFICE ACTION DATED FEBRUARY 26, 2003

In response to the Office Action dated February 26, 2003, having a shortened statutory period for response set to expire on May 26, 2003, please enter the following amendments and reconsider the claims pending in the application for reasons discussed below. Applicants have submitted herewith a petition for a one month extension of time under 37 CFR §1.136(a). Although Applicants believe that no fee is due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/4969/CMP/ECP/NAN, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

IN THE SPECIFICATION:

Please add the following text to page 1, line 6, after the ".":

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OFFICE OF PETITIONS